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\*\* CONTINUING DATA \*\*\*\*\*

None CAT

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

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Verified and Acknowledged Examiner's Signature <u>CAT</u> Initials <u>CAT</u>	KOREA, REPUBLIC OF	6	36	4

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## TITLE

Crystallization method of silicon thin film, thin film transistor manufactured using the method, and flat panel display including the thin film transistor

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